



IFW

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q79867

Nobuyuki ETO, et al.

Appln. No.: 10/777,680

Group Art Unit: 1731

Confirmation No.: 5870

Examiner: Not Yet Assigned

Filed: February 13, 2004

For: METHOD OF PROCESSING A GLASS SUBSTRATE FOR A MAGNETIC DISK  
AND METHOD OF MANUFACTURING THE GLASS SUBSTRATE

**STATUS INQUIRY**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The undersigned respectfully requests to be advised of the status of the above-identified application.

Respectfully submitted,

*Ronald Kimble 44,186*  
*for*

SUGHRUE MION, PLLC  
Telephone: (202) 293-7060  
Facsimile: (202) 293-7860

Alan J. Kasper  
Registration No. 25,426

WASHINGTON OFFICE

**23373**

CUSTOMER NUMBER

Date: April 21, 2005